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CENTRAL FAX CENTERU.S. Patent Application No. 10/789,330
Attorney Docket No. ABS-1460 USLISTING OF CLAIMS

JUN 27 2007

1. (Currently Amended) A cleaning unit for cleaning a slit coater for coating a substrate with a material, said cleaning unit comprising:

a body including an upper face, the upper face having a receiving recession for receiving a slit nozzle of the slit coater, the receiving recession having a sidewall and a bottom face, the sidewall having a first injection hole, a cleaning material being sprayed via the first injection hole; and

a cleaning member covering the bottom face of the receiving recession to eliminate ~~for eliminating~~ dregs of the material attached on the slit nozzle of the slit coater, ~~the cleaning member covering the bottom face of the receiving recession.~~

2. (Original) The cleaning unit of claim 1, wherein the cleaning member comprises an elastic material.

3. (Previously Presented) The cleaning unit of claim 2, wherein the elastic material is rubber or polytetrafluoroethylene.

4. (Previously Presented) The cleaning unit of claim 1, wherein the cleaning member is detachably attached on the bottom face.

5. (Original) The cleaning unit of claim 1, wherein the sidewall has a second injection hole, gas being sprayed via the second injection hole so as to dry the slit nozzle of the slit coater.

6. (Original) The cleaning unit of claim 1, wherein gas is sprayed via the first injection hole so as to dry the slit nozzle of the slit coater, after spraying the cleaning material.

7. (Original) The cleaning unit of claim 1, wherein the slit nozzle of the spin coater includes a first inclined face, a second inclined face and a connection face connecting the first inclined face with the second inclined face, the connection face having a slit for discharging the photosensitive material, the sidewall of the receiving recession includes a third inclined face and a fourth inclined face, the first inclined face being substantially parallel with the third inclined face and the second inclined face being substantially parallel with the fourth inclined face.

8. (Previously Presented) A cleaning unit for cleaning a slit coater for coating a substrate with a material, said cleaning unit comprising:

a body including an upper face, the upper face having a receiving recession for receiving a slit nozzle of the slit coater, the receiving recession having a sidewall and a bottom face, the sidewall having a first injection hole, a cleaning material being sprayed via the first injection hole, wherein the slit nozzle of the spin coater includes a first inclined face, a second inclined face and a connection face connecting the first inclined face with the second inclined face, the connection face having a slit for discharging the photosensitive material, the sidewall of the receiving recession includes a third inclined face and a fourth inclined face, the first inclined face being substantially parallel with the third inclined face and the second inclined face being substantially parallel with the fourth inclined face; and

a cleaning member for eliminating dregs of the material attached on the slit nozzle of the slit coater, the cleaning member being attached on the bottom face of the receiving recession, wherein the cleaning member of the cleaning unit makes contact with the connection face of the slit nozzle of the slit coater during a cleaning process.

9. (Original) The cleaning unit of claim 1, wherein the material corresponds to a photosensitive material.

10-21. (Canceled)